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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:
Paul Shirley et al.

Serial No.: 10/765,481

Filed: January 27, 2004

For: METHOD AND APPARATUS
FOR A TWO-STEP RESIST SOFT
BAKE TO PREVENT ILD
OUTGASSING DURING
SEMICONDUCTOR PROCESSING

§
§ Group Art Unit: 2823
§
§
§ Examiner: Toledo, Fernando L.
§
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§ Atty. Docket: MICS:0117/FLE/FAR
§ 02-1051
§
§

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:	
January 9, 2006 Date	 Michael G. Fletcher

**AMENDMENT AND RESPONSE TO
OFFICE ACTION MAILED NOVEMBER 9, 2005**

In response to the Office Action mailed November 9, 2005, please amend the above-identified application as follows: